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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hongyong Zhang

Art Unit : 2814

Serial No. : 09/362,808

Examiner : Shrinivas H. Rao

Filed : July 28, 1999

Title : METHOD OF FABRICATING SEMICONDUCTOR DEVICE

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicants request consideration of the references listed on the attached PTO-1449 form. Under 37 C.F.R. § 1.98 (a)(2)(ii), only copies of foreign patent documents and/or non-patent literature are enclosed. Copies of any listed U.S. patents or U.S. patent application publications can be provided upon request.

This statement is being filed after a first Office action on the merits, but before receipt of a final Office action or a Notice of Allowance. I, the undersigned, hereby certify that each item of information contained in this statement was cited in a communication from a foreign patent office in a counterpart foreign application, the communication being dated October 18, 2005, which is not more than three months prior to the filing of this statement. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: 1/18/06
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Substitute Form PTO-1449 (Modified)		U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 07977-088002	Application No. 09/362,808
Information Disclosure Statement by Applicant (Use several sheets if necessary)		Applicant Hongyong Zhang		
(37 CFR §1.98(b))		Filing Date July 28, 1999	Group Art Unit 2814	

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents or Published Foreign Patent Applications							
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Sub-class	Translation
							Yes No
	AL	EP0 263 220	13 APR 1988	EUROPE			In English
	AM	JP63-104338	09 MAY 1988	JAPAN			Abstract
	AN	JP64-033971	03 FEB 1989	JAPAN			Full
	AO	JP01-286443	17 NOV 1989	JAPAN			Full
	AP	JP06-104281	15 APR 1994	JAPAN			Full

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
	AQ	
	AR	
	AS	
	AT	

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	